

Pre Trial H

219288US-2 PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF: :
 YASUTAKA ITO ET AL. : ATTN: APPLICATION DIVISION
 SERIAL NO: 10/049,293 :
 FILED: February 11, 2002 :
 FOR: CERAMIC HEATER

PRELIMINARY AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
 WASHINGTON, D.C. 20231

SIR:

Prior to a first examination on the merits, please amend the above-identified application as follows:

IN THE CLAIMS

Please amend claims 3 and 4 to read as follows:¹

-
- A.* 3. (Amended) The ceramic heater for heating a semiconductor wafer according to claim 1,
 wherein said temperature-measuring means is a temperature-measuring element.
 4. (Amended) The ceramic heater for heating a semiconductor wafer according to claim 1,

¹A marked-up copy of the claim amendments is attached hereto.